SEMICONDUCTOR AND CLEANROOM PRODUCTS



Micro Technologies, Big Ideas.

PRODUCT INFORMATION

Model 2001 and 2010—Ultrapure Cleanroom Foggers

- A non-contaminating fog generator for producing high-purity water fog for air flow visualization in cleanrooms
- Leaves no residue contaminants when droplets evaporate
- Suitable for photographic or video recording of air flow patterns in cleanrooms



DESCRIPTION

The Models 2001 and 2010 are high-purity fog generators designed for air flow visualization in cleanrooms. These fog generators produce a high-density fog by quenching steam with liquid nitrogen to produce small (~3µm in diameter), pure water droplets suspended in a nitrogen carrier gas. The resulting fog is highly visible and truly non-contaminating. The droplets leave no measurable residues when they evaporate in the cleanroom air. These foggers can meet the most stringent demands of the modern semiconductor and pharmaceutical cleanrooms. The non-contaminating nature of these fog generators makes them suitable for use in an operating cleanroom without interrupting ongoing production or other activities taking place in the cleanroom.

FEATURES

- M2001 is a full-size fogger for generating a steady fog stream for up to ~45 minutes in duration
- M2010 is a small, portable fogger for generating a steady fog for up to ~25 minutes in duration
- Small (~3μm) droplet size and neutrally buoyant fog for airflow tracking over long distances
- Equipped with 2.5-meter flexible hose and 3-piece extendable wand assembly for convenient directional control of fog output





APPLICATIONS

- Visualize and track air flow faithfully in cleanrooms to determine the airflow trajectory for:
 - Troubleshooting
 - Photographic or video recording of air flow patterns
 - Flow balancing
 - Optimizing equipment location to minimize contaminant transport to critical areas
 - Finding unsuspected particulate and gaseous contaminant sources
 - Finding routes of air infiltration into the cleanroom
 - Visualizing standing vortices in laminar-flow cleanrooms
 - Studying wake flow behind objects in vertical laminarflow and mixed-flow cleanrooms
 - Operator training on good contamination control practices

- Air flow visualization in and around:
 - Mini-environments
 - Clean benches and hoods
 - Ventilation and exhaust hoods.
 Architectural features such as doors



SPECIFICATIONS

Subject to change without notice

Ultrapure Cleanroom Fogger

	M2001	M2010
Dimensions	533x406x381mm	457x356x356mm
(WxHxD)	21"x16"x15"	18"x14"x14"
Weight	25 kg (55 lb)	20 kg (45 lb)
Boiler Volume	3 Liter	2 Liter
Dewer Volume	9 Liter	3 Liter
Power	115VAC50/60Hz 15A	115VAC50/60Hz 10A
Optional	220VAC50/60Hz 10A	220VAC50/60Hz 10A

Standard Accessories Provided

2.5 meter (8 ft) of nominal 30mm (1-1/4") diameter flexible fog hose and 3-piece wand.

MSP Corporation

5910 Rice Creek Parkway, Suite 300 Shoreview, Minnesota 55126, U. S. A. Phone: 651.287.8100; Fax: 651.287.8140 sales@mspcorp.com; www.mspcorp.com

Copyright© MSP Corporation (MSP-Pl2001-2010, Rev.B). The MSP logo is a registered trademark of MSP Corporation. Ultrapure Cleanroom Fogger is a trademark of MSP. All rights reserved.